
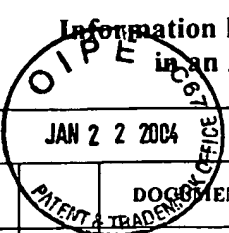


PTO-1449			Application No. Unassigned		Applicant(s) Pascal Huyghe et al.		
<b>Information Disclosure Citation in an Application</b>			Docket Number 064441.0263		Group Art Unit Unknown		Filing Date June 27, 2003
<b>U.S. PATENT DOCUMENTS</b>							
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	A.						
	B.						
	C.						
	D.						
	E.						
	F.						
	G.						
	H.						
	I.						
	J.						
	K.						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	L.						
	M.						
	N.						
	O.						
	P.						
	Q.						
<b>NON-PATENT DOCUMENTS</b>							
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE
MA	R.	Edward Suttle et al.'s "Streamlining the front-end reticle fabrication process by improving mask ordering" at internet address < <a href="http://www.micromagazine.com/archive/02/06/suttle.html">http://www.micromagazine.com/archive/02/06/suttle.html</a> > and published in June 2002 Issue of Micro Magazine. 10 Pages					June 2002
MA	S.	Brock Hotaling, "MaskPilot Revolutionizes Semiconductor Software," <u>Reticle and Mask Solutions</u> , Vol. I, No. 1, Fall 2002, 4 Pages					Fall 2002
	T.	Photronics, Inc., "Photronics eBeam Phase Masks: Tackling the Challenges of Special Lightwave Applications," <u>Reticle and Mask Solutions</u> , Vol. XIII, No. 1, Spring 2002, 4 Pages					Spring 2002
EXAMINER					DATE CONSIDERED		
					2/24/2006		
<p>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.</p>							

PTO-1449		Application No. 10/607,944		Applicant(s) Pascal Huyghe et al.			
<b>Information Disclosure Citation in an Application</b> 		Docket Number 064441.0263		Group Art Unit 2122	Filing Date June 27, 2003		
		JAN 22 2004 U.S. PATENT DOCUMENTS					
	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
MA A.	5909570	6/1/99	Webber	395	500	6/9/97	
MA B.	6012070	1/4/00	Cheng et al.	707	505	11/15/96	
MA C.	2002/0184266	12/5/02	Blessin	707	513	3/20/02	
D.							
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I.							
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K.							
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
MA L.	01/63446 A2 ✓	8/30/01	WO	G06F	17/00	X	
MA M.	02/03141 A2 ✓	1/10/02	WO	G03F	1/00	X	
N.							
O.							
P.							
Q.							
NON-PATENT DOCUMENTS							
	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)						DATE
MA R.	✓ PCT International Search Report application number PCT/US03/20345, 7 pages.						Mailing 12/19/03
S.							
T.							
EXAMINER <i>Haynes</i>				DATE CONSIDERED 2/24/2006			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							